

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) 46955.20		Application Number 10/519349			
				Applicant(s) Hillenbrand, et al. / Customer Number 041068					
				Filing Date 27 December 2004 (371 date)				Group Art Unit 2884	
				Not Yet Assigned					
U.S. PATENT DOCUMENTS									
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
/C/	AA	6408123	18 Jun 2002	Kuroda, et al.			9 Nov 2000		
/C/	AB	5602820	11 Feb 1997	Wickramasinghe, et al.			24 Aug 1995		
/C/	AC	4947034	7 Aug 1990	Wickramasinghe, et al.			28 Apr 1989		
U.S. PATENT APPLICATION PUBLICATIONS									
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
FOREIGN PATENT DOCUMENTS									
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation		
							YES	NO	
/C/	AD	DE 10035134 A1	14 Feb 2002	Germany			<input checked="" type="checkbox"/>		
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>									
/C/	AE	S. KLABITZER; "Generation of optical contrast in insulating materials by irradiation with focused ion beams", Applied Physics A, Vol. 71, pp 565-569.							
/C/	AF	R. HILLENBRAND, et al.; "Material-specific mapping of metal/semiconductor/dielectric nanosystems at 10 nm resolution by backscattering near-field optical microscopy", Applied Physics Letters, Vol. 80 Number 1, (2002), pp25-27.							
EXAMINER /Carolyn Igyarto/				DATE CONSIDERED 11/12/2007					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)
46955.20

Application Number
10/519349

Applicant(s)
Hillenbrand, et al. / Customer Number 041068

Filing Date
27 December 2004 (371 date)

Group Art Unit 2884
~~Not Yet Assigned~~

*EXAMINER INITIAL	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
/CII	AG	R. HILLENBRAND, et al.; "Complex Optical Constants on a Subwavelength Scale", Physical Review Letters, Vol. 85, No. 14, 2000, pp 3029-3032.
/CII	AH	Y. MARTIN, et al.; "Optical data storage read out at 256 Gbits/in.2", Applied Physics Letters, Vol. 71, 1997, pp 1-3.
/CII	AI	B. KNOLL, et al.; "Infrared conductivity mapping for nanoelectronics", Applied Physics Letters; Vol. 77, No. 24, 2000, pp 3980-3982.
/CII	AJ	B. KNOLL, et al.; "Near-field probing of vibrational absorption for chemical microscopy", Nature, Vol. 399, 1999, pp 134-136.
/CII	AK	P.K. ARAVIND, et al.; "The effects of the interaction between resonances in the electromagnetic response of a sphere-plane structure; applications to surface enhanced spectroscopy", Surface Science, Vol. 124, 1983, pp 506-528.
/CII	AL	B. KNOLL, et al.; "Enhanced dielectric contrast in scattering-type scanning near-field optical microscopy", Optics Communications, Vol. 182, No. 4-6, 2000, pp 321-328
/CII	AM	F. KEILMANN, et al.; "Long-Wave-Infrared Near-Field Microscopy", physica status solidi, Vol. 215 ISS.1, 1999, pp 321-328.
/CII	AN	T.R. JENSEN, et al.; "Nanosphere Lithography: Tunable Localized Surface Plasmon Resonance Spectra of Silver Nanoparticles", J. Phys. Chem. B, Vol. 104, No. 45, 2000, pp 10549-10556.
EXAMINER		DATE CONSIDERED
/Carolyn Igyarto/		11/12/2007

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.